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Fred M. Dickey
David L. Shealy
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Contents

vii *Conference Committee*

SESSION 1 THEORY

- 6663 02 **Micro lens laser beam homogenizer: from theory to application (Invited Paper)** [6663-01]
M. Zimmermann, Bayerisches Laserzentrum GmbH (Germany); N. Lindlein, Institute of Optics, Information and Photonics, Univ. of Erlangen (Germany); R. Voelkel, K. J. Weible, SUSS MicroOptics SA (Switzerland)
- 6663 03 **Impact of phase errors at the conjugate step on the propagation of intensity and phase shaped laser beams** [6663-02]
I. A. Litvin, CSIR National Laser Ctr. (South Africa) and Univ. of Stellenbosch (South Africa); A. Forbes, CSIR National Laser Ctr. (South Africa) and Univ. of Kwazulu-Natal (South Africa)
- 6663 04 **Caustic surfaces in a Keplerian two-lens beam shaper** [6663-03]
J. A. Hoffnagle, IBM Almaden Research Ctr. (USA); D. L. Shealy, Univ. of Alabama, Birmingham (USA)
- 6663 05 **A model of the transverse modes of stable and unstable porro-prism resonators using symmetry considerations** [6663-04]
L. Burger, A. Forbes, CSIR National Laser Ctr. (South Africa) and Univ. of Kwazulu-Natal (South Africa)
- 6663 06 **Unwound vortex beam shaping** [6663-05]
C. López-Mariscal, J. C. Gutiérrez-Vega, Tecnológico de Monterrey (Mexico)
- 6663 07 **Propagation dynamics of helical Hermite-Gaussian beams** [6663-06]
C. López-Mariscal, J. C. Gutiérrez-Vega, Tecnológico de Monterrey (Mexico)

SESSION 2 DESIGN

- 6663 08 **Beam shaping on the base of micro lenslet arrays with the help of diffraction and interference effects** [6663-07]
Yu. Miklyaev, D. Hauschild, A. Mikhailov, V. Lissotschenko, LIMO Lissotschenko Mikrooptik GmbH (Germany)
- 6663 09 **Fly's eye condenser based on chirped microlens arrays** [6663-08]
F. C. Wippermann, U.-D. Zeitner, P. Dannberg, A. Bräuer, Fraunhofer Institute for Applied Optics and Precision Engineering (Germany); S. Sinzinger, Technical Univ. of Ilmenau (Germany)
- 6663 0A **Laser profile uniformity at the image plane: comparing hard and digital apertures illuminated by a diffractive optical beam shaper** [6663-09]
T. E. Lizotte, Hitachi Via Mechanics USA, Inc. (USA)

- 6663 0C **Designing beam shaping systems basing on spherical catalog lenses** [6663-11]
H. Schimmel, LightTrans GmbH (Germany); F. Wyrowski, Friedrich Schiller Univ. (Germany)

SESSION 3 FABRICATION AND TECHNIQUES I

- 6663 0D **Refractive beam shaping: from Maxwell's Equations to products and applications in laser materials processing (Invited Paper)** [6663-13]
O. Homburg, D. Hauschild, P. Harten, L. Aschke, V. Lissotschenko, LIMO Lissotschenko Mikrooptik GmbH (Germany)
- 6663 0E **Vacuum isostatic micro molding of diffractive structures into PTFE materials** [6663-14]
T. E. Lizotte, O. Ohar, Hitachi Via Mechanics USA, Inc. (USA)
- 6663 0F **Methods of designing and fabricating: an equilateral triangle beam splitter** [6663-15]
J. G. Smith, A. Stockham, MEMS Optical, Inc. (USA)

SESSION 4 FABRICATION AND TECHNIQUES II

- 6663 0G **High power holographic masks for beam shaping** [6663-17]
W. Parker, Creative MicroSystems Corp. (USA)
- 6663 0H **Characterisation of a spinning pipe gas lens using a Shack-Hartmann wavefront sensor** [6663-18]
C. Mafusire, A. Forbes, CSIR National Laser Ctr. (South Africa) and Univ. of Kwazulu-Natal (South Africa); G. Snedden, CSIR Defence Peace Safety and Security (South Africa); M. M. Michaelis, Univ. of Kwazulu-Natal (South Africa)
- 6663 0I **New approaches for manufacturing refractive beam shapers** [6663-19]
S. Kiontke, asphericon GmbH (Germany)

SESSION 5 APPLICATIONS

- 6663 0J **Innovative optical technique speeds up LED wafer scribing production (Invited Paper)** [6663-20]
L. Chen, R. Y. L. Hsu, R. J. Z. Lee, Uni-Via Technology Inc. (Taiwan); T. Lizotte, Hitachi Via Mechanics USA, Inc. (USA)
- 6663 0K **Beam shaping for cosmetic hair removal** [6663-21]
T. E. Lizotte, T. Tuttle, Hitachi Via Mechanics USA, Inc. (USA)
- 6663 0L **Wafer dicing utilizing unique beam shapes** [6663-22]
T. Lizotte, O. Ohar, Hitachi Via Mechanics USA, Inc. (USA)
- 6663 0M **Advances in MEMS deformable mirror technology for laser beam shaping** [6663-23]
S. Menn, S. A. Cornelissen, P. A. Bierden, Boston Micromachines Corp. (USA)
- 6663 0N **Increased efficiency and performance in laser pump chambers through use of diffuse highly reflective materials** [6663-24]
B. Waldwick, C. Chase, B. Y. Chang, Labsphere, Inc. (USA)

- 6663 0O **The main peculiarities of arranging the optical scheme of acousto-optical spectrometer for the Mexican Large Millimeter Telescope** [6663-25]
A. S. Shcherbakov, S. E. Balderas Mata, E. Tepichin Rodriguez, A. Luna Castellanos,
D. Sanchez Lucero, National Institute for Astrophysics, Optics and Electronics (Mexico);
J. Maximov, Molecular Technology GmbH (Germany)
- 6663 0Q **A design of optical resonator for donut mode generation** [6663-27]
S.-C. Chu, National Cheng Kung Univ. (Taiwan)

POSTER SESSION

- 6663 0R **Laser beam shaping limitations for laboratory simulation of turbulence using a phase-only spatial light modulator** [6663-28]
I. A. Litvin, CSIR National Laser Ctr. (South Africa) and Univ. of Stellenbosch (South Africa);
L. Burger, M. P. De Gama, A. Mathye, A. Forbes, CSIR National Laser Ctr. (South Africa) and
Univ. of Kwazulu-Natal (South Africa)
- 6663 0S **Propagation of Helmholtz-Gauss beams in turbulent media** [6663-31]
R. J. Noriega-Manez, J. C. Gutierrez-Vega, Tecnológico de Monterrey (Mexico)
- 6663 0T **Characterization of higher-order Mathieu X-waves in the optical domain** [6663-32]
J. Davila, J. C. Gutiérrez-Vega, Tecnológico de Monterrey (Mexico)

Author Index

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- 2 Design
Andrew Forbes, Council for Scientific and Industrial Research
(South Africa) and University of Kwazulu-Natal (South Africa)
- 3 Fabrication and Techniques I
Todd E. Lizotte, Hitachi Via Mechanics USA, Inc. (USA)
- 4 Fabrication and Techniques II
Todd E. Lizotte, Hitachi Via Mechanics USA, Inc. (USA)
- 5 Applications
David L. Shealy, The University of Alabama, Birmingham (USA)